



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Deva N. Pattanayak,
Assignee: Siliconix incorporated
Title: Triple-Diffused Trench MOSFET And Method Of Fabricating The Same
Serial No.: 10/657,830 Filing Date: 09/08/03
Examiner: Mai-Huong Tran Group Art Unit: 2818
Docket No.: SCX015 US Confirmation No.: 1749

Santa Clara, California
December 21, 2004

COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In Response to the Office Action dated November 9, 2004, Applicants elect without traverse to have the invention of Group II, Claims 1-11, examined. Please withdraw from consideration Claims 12-18, which are drawn to the invention of Group I. Applicants reserve the right to seek examination of the invention of Group I in a divisional application.

Should the Examiner have any questions concerning this response, the Examiner is invited to call the undersigned at (408) 982-8200, ext. 1.

CERTIFICATE OF MAILING BY "FIRST CLASS"

I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the below date.

David E. Steuber
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12/21/04
Date of Signature

Respectfully submitted,

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